

S/N 09/815,919

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Mark L. Jenson

Examiner: Bruce F. Bell

Serial No.: 09/815,919

Group Art Unit: 1746

Filed: March 23, 2001

Docket: 1327.003US1

Title: LOW-TEMPERATURE FABRICATION OF THIN-FILM ENERGY-STORAGE DEVICES

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 et. seq., the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicants respectfully request that this Supplemental Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicants request that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicants with the next official communication.

Pursuant to 37 C.F.R. §1.97(c)(2), Applicants believe no fee is due because of the RCE filed herewith. Please charge any required additional fees or credit any overpayment to Deposit Account No. 502931. The Examiner is invited to contact the Applicants' Representative at the below-listed telephone number if there are any questions regarding this communication.

RESPECTFULLY SUBMITTED,  
MARK L. JENSON  
BY HIS REPRESENTATIVES,

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17 Sept 2004

BY

Charles A. Lemaire

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CERTIFICATE UNDER 37 CFR 1.8:

The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 17th day of September, 2004.

Charles A. Lemaire  
Name

Signature

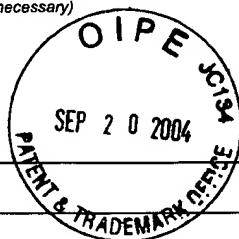
Charles A. Lemaire

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Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)



Complete if Known

<b>Application Number</b>	09/815,919
<b>Filing Date</b>	March 23, 2001
<b>First Named Inventor</b>	Mark L. Jenson
<b>Group Art Unit</b>	1746
<b>Examiner Name</b>	Bruce F. Bell

Sheet 1 of 1

Attorney Docket No: 1327.003US1

**US PATENT DOCUMENTS**

Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	Filing Date If Appropriate
	US-5,433,096	07/18/1995	Janssen, David C., et al.	70	278	08/26/1993
	US-5,914,507	06/22/1999	Polla, Dennis L., et al.	257	254	10/30/1996
	US-5,953,677	09/14/1999	Sato, Y.	455	574	09/08/1997
	US-6,238,813	05/29/2001	Maile, Keith R., et al.	429	9	07/24/1998
	US-6,327,909	11/30/1999	Hung, E., et al.	73	514.16	11/30/1999
	US-6,432,577	08/13/2002	Shul, Randy J., et al.	429	162	06/29/2000
	US-6,558,836	05/06/2003	Whitacre, Jay F., et al.	429	162	02/08/2001
	US-6,610,971	08/26/2003	Crabtree, D.	244	3.1	05/07/2002
	US-6,634,232	10/21/2003	Rettig, R., et al.	73	514.15	09/19/2002

**FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	T <sup>2</sup>
	JP-6196178	07/15/1994	Mutso, Kakigi, et al.	H01M	008/2	

**OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		LUGSCHEIDER, E., et al., "Comparison of the Structure of PVD-Thin Films Deposited With Different Deposition Energies", <u>Surface and Coatings Technology</u> , 86-87 (1-3), (December 1, 1996), 177-183	
		MCKENZIE, D. R., et al., "New Technology for PACVD", <u>Surface and Coatings Technology</u> , 82 (3), (1996), 326-333	
		SHUKLA, A. K., et al., "Electrochemical supercapacitors: Energy storage beyond batteries", <u>Current Science</u> , Vol 79, No. 12, (Dec 25, 2000), 1656-1661	

**EXAMINER****DATE CONSIDERED**

Substitute Disclosure Statement Form (PTO-1449)

\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup> Applicant's unique citation designation number (optional) <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached